

PATENT ASSIGNMENT

Electronic Version v1.1

Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
Mary Kathryn Gutberlet	08/22/2007
Rambod Nader	08/29/2007
Michael Andrew Parker	08/23/2007
Douglas Johnson Werner	08/21/2007
RECEIVING PARTY DATA	
Name:	Hitachi Global Storage Technologies Netherlands B.V.
Street Address:	Locatellikade 1
Internal Address:	Parnassustoren
City:	1076 AZ Amsterdam
State/Country:	NETHERLANDS
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	13038313
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Total Attachments: 1 source=HIT1P405A_signedassign#page1.tif	

CH \$40.00 13038313

PATENT

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REEL: 026593 FRAME: 0014

ASSIGNMENT

Whereas, I Mary Kathryn Gutberlet of Prunedale, County of Monterey, Rambod Nader of Campbell, County of Santa Clara, Michael Andrew Parker of Fremont, County of Alameda, and Douglas Johnson Werner of Fremont, County of Alameda and State of California have invented certain improvements in **PHOTOLITHOGRAPHIC METHOD AND MASK DEVICES UTILIZED FOR MULTIPLE EXPOSURES IN THE FIELD OF A FEATURE** and executed, respectively, a United States patent application therefor on August 22, 2007, August 29, 2007, August 23, 2007, and August 21, 2007;

Whereas, HITACHI GLOBAL STORAGE TECHNOLOGIES NETHERLANDS B.V., having a place of business at Locatellikade 1, Parnassustoren 1076 AZ Amsterdam, The Netherlands, (hereinafter called HITACHI), desires to acquire the entire right, title and interest in the said application and invention, and to any United States and foreign patents to be obtained therefor;

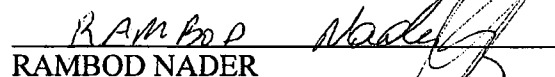
Now therefore, for a valuable consideration, receipt whereof is hereby acknowledged, I, the above named, hereby sell, assign, and transfer to HITACHI, its successors and assigns, the entire right, title and interest in the said application and invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing of said United States application, and I request the Commissioner of Patents to issue any Letters Patent granted upon the inventions set forth in said application to HITACHI, its successors and assigns; and I hereby agree that HITACHI may apply for foreign Letters Patent on said invention and I will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by HITACHI.

Signed

At San Jose
on August 22, 2007


MARY KATHRYN GUTBERLET

At San Jose
on August 29, 2007


RAMBOD NADER

At San Jose
on August 23, 2007


MICHAEL ANDREW PARKER

At San Jose
on August 21, 2007


DOUGLAS JOHNSON WERNER